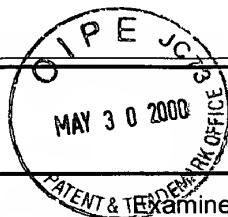


Sep 1765

TRANSMITTAL LETTER
(General - Patent Pending)

Docket No.
11675.114

In Re Application Of: Kei-Yu Ko



Serial No.
08/846,671

Filing Date
April 30, 1997

Examiner
George A. Goudreau

Group Art Unit
1765

Title: **UNDOPED SILICON DIOXIDE AS ETCH STOP FOR SELECTIVE ETCH OF
DOPED SILICON DIOXIDE**

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TO THE ASSISTANT COMMISSIONER FOR PATENTS:

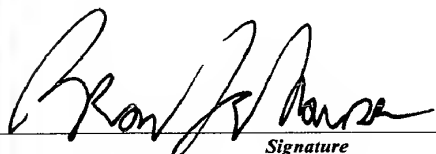
Transmitted herewith is:

Combined Amendment and Petition for Extension of Time (2 pgs); Amendment B (15 pgs); Copy of English Translation of Japanese patent; Check No. 115701 in the amount of \$110; Postcard

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in the above identified application.

- ☐ No additional fee is required.
- ☒ A check in the amount of **\$110.00** is attached.
- ☒ The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. **23-3178** as described below. A duplicate copy of this sheet is enclosed.
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Dated: May 25, 2000



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